

AMENDMENTS TO THE SPECIFICATION:

Please amend the paragraph beginning at page 8, line 14 of the Specification as follows.

--As the voltage is variable, the electric field varies depending on the voltage. Thus, the axial deformations of the piezoelectric ceramics forming each sector 123, 124, 133, 134 follow, depending on their polarity, the variations in intensity of the axial electric field to which they are subjected. Thus, when the intensity of the electric field increases, the thickness of one sector of a wafer increases whilst the thickness of the other sector of the same wafer decreases, and reciprocally when the intensity of the electric field decreases. When the intensity of the voltage, and therefore of the fields, varies, the thicknesses also vary progressively, exciting progressively each of the bending modes M1, M2 so that each point on the line L describes around the axis X a path shown approximately as a circle in FIG. 1 by the arrow R.--